Form PTO-1449 epartment of Commerce Atty Docket 0756-2203 Serial No. Unassigned (Rev. 8-69) Patent and Trademark Office Applicants: Shunpei YAMAZAKI #2 INFORMATION DISCLOSURE STATEMENT Filing Date: April 12, 2001 Group Art Unit: 1765 **U.S. PATENT DOCUMENTS** Examiner **Document Number** Date Name Class **Subclass** Filing Date Initial (if appropriate) 2,819,191 01/07/1958 **Fuller** MLT 4,068,020 01/10/1978 REUSCHEL.K 4,103,297 07/25/1978 MCGREIVY.D et al. 4,239,346 12/16/1980 Lloyd BRODSKY.M et al. 4,363,828 12/14/1982 12/21/1982 ISHIOKA.S et al. 4,365,013 4,378,417 MARUYAMA.E 03/19/1983 4,395,726 07/26/1983 MAEGUCHI.K HAMAGUCHI: Torrige, sto. 4,438,654 03/27/1984 OGAWA.K et al. 4,460,670 07/17/1984 YAMAZAKI.S 4,470,060 09/04/1984 T 4,500,388 02/19/1985 OHMURA.Y et al. 4,565,584 01/21/1986 TAMURA.M et al. 4,581,476 04/08/1986 YAMAZAKI.S 4,581,620 04/08/1986 YAMAZAKI.S et al. 4,584,025 04/22/1986 TAKAOKA.M et al. 4,591,892 05/27/1986 YAMAZAKI.S 4,597,160 07/01/1986 IPRI.A 4,621,276 11/04/1986 MALHI.S 4,651,408 03/24/1987 MACELWEE.T et al. 4,659,392 04/21/1987 **VASUDEV.P** 4,680,580 07/14/1987 KAWAHARA.Y 4,690,717 09/01/1987 YAMAZAKI.S 4,693,759 09/15/1987 NOGUCHI.T et al. 4,697,887 10/06/1987 Okada et al. 4,729,009 03/01/1988 ANG.S 4,740,829 04/26/1988 NAKAGIRI. Tet al. 4,743,567 05/10/1988 PANDYA.R et al. 4,755,865 07/05/1988 WILSON.S et al. YAMAZAKI.S et al. 4,760,008 07/26/1988 4,766,477 NAKAGAWA.K et al. 08/23/1988 MLT Minhloan Tran 5102 Examiner Date Considered \*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this formwith next communication to applicant,

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(Rev.	8-8©)

epartment of Commerce Patent and Trademark Office

Atty Docket 0756-2266

Serial No. Unassigned

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI

Group Art Unit: 1765

Filing Date: April 12, 2001

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\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this formwith next communication to applicant.

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		_	Filing Date: April 12, 2001		Group Art	Unit: 1765
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\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this formwith next communication to applicant.

Date Considered

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INFORM	1ATION DISCLOSURE STAT	EMENT	Applicants: Shunpei YAM	<b>AZAKI</b>	09/83	2,844
			Filing Date: April 12, 200	1	Group Art	Unit: 1765
	<del>.</del>	U.S. PATENT	DOCUMENTS			
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Date Considered

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Form PTO-1449 epartment of Commerce Atty Docket 0756-2288 Serial No. Unassigned . (Rev. 8-83) Patent and Trademark Office Applicants: Shunpei YAMAZAKI INFORMATION DISCLOSURE STATEMENT Filing Date: April 12, 2001 **Group Art Unit: 1765 U.S. PATENT DOCUMENTS Document Number** Class Filing Date Examiner Date Name Subclass Initial (if appropriate) YAMAZAKI.S et al. 5,818,070 10/06/1998 MLT 5,846,320 12/08/1998 Matsuyama et al. 5,849,601 12/15/1998 Yamazaki 5,851,440 12/22/1998 Tanaka et al. 5,889,291 03/30/1999 KOYAMA.J et al. 05/18/1999 5,904,511 Misawa et al. 08/03/1999 YAMAZAKI.S et al. 5,933,205 5,963,278 10/05/1999 YAMAZAKI.S et al. MLT **FOREIGN PATENT DOCUMENTS** Examiner **Document Number** Date Class Subclass Country Translation Initial No Full Eng 06/02/1987 0 161 555 EP MLT Eng Abst 0 321 073 06/21/1989 EP Full Eng 10/18/1989 0 337 457 EP Eng Abst 01-107237 04/25/1989 JP Eng Abst 01-128534 05/22/1989 JP 05/23/1989 Eng Abst 01-130131 JP Full Eng 01-156725 06/20/1989 JP 09/06/1989 Eng Abst 01-223719 JP 10/25/1989 JP Eng Abst 01-268064 Eng Abst 01-289917 11/21/1989 JΡ 02/21/1990 Eng Abst 02-051129 JP Eng Abst 03/01/1990 JP 02-062077 03/30/1990 JP 02-090531 04/17/1990 Eng Abst 02-103925 JP Eng Abst 02-115824 04/27/1990 JP 05/08/1990 Eng Abst 02-120330 JP Eng Abst 02-137822 05/28/1990 JΡ Eng Abst 02-174170 07/05/1990 JP 02-188723 07/24/1990 JP Eng Abst Eng Abst 08/10/1990 02-201967 JP MLT Minhloan Tran 5102 Examiner Date Considered \*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this formwith next communication to applicant.

Form PTO-1449 (Rev. 8-83) Department of Commerce Patent and Trademark Office

Atty Docket 0756-2288

Serial No. Unassigned

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI

Filing Date: April 12, 2001 Group Art Unit: 1765

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\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this formwith next communication to applicant.

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Atty Docket 0756-2268

Filing Date: April 12, 2001

Serial No. Unassigned

INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI

Group Art Unit: 1765

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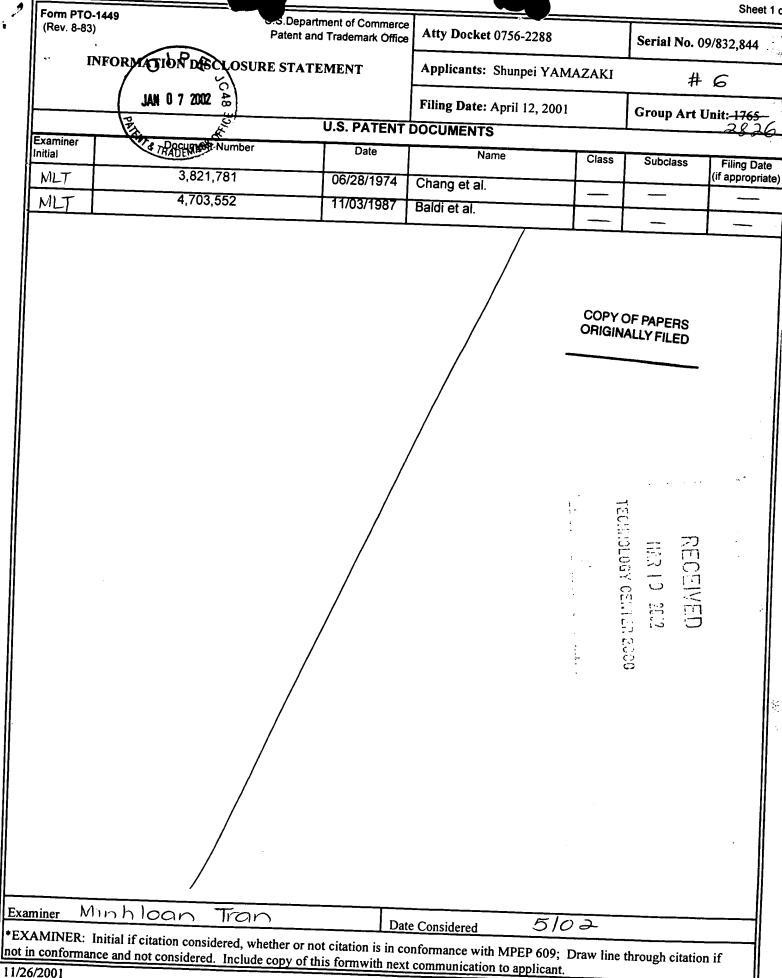
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• İi	NFORMATION DISCLOSURE STAT	EMENT	Applicants: Shunpei YAM	AZAKI	09/03	2844
			Filing Date: April 12, 2001		Group Art U	/ Init: 1765
	F	OREIGN PATE	NT DOCUMENTS		<u> </u>	
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	Inventors: Jun Koyama et al., Specifica 11/24/1999, ., "Redundancy Shift Regi					
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Examiner	Minhloan Tran		Date Considered	5/02		
*EXAMIN	IER: Initial if citation considered, whether		in conformance with MPEP 6		line through cit	ation if

Form PTO-1 (Rev. 8-83)	149	Department of Commerce Patent and Trademark Office	Atty Docket 0756-2268	Serial No. Unassigned
in A	FORMATION DISCLOSU	JRE STATEMENT	Applicants: Shunpei YAMAZAKI	O9837,844
			Filing Date: April 12, 2001	Group Art Unit: 1765 28
		OTHER DOCUMENTS	(Including Author, Title, Date, Pertinent Page	s, Etc.)
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Examiner	Minhloan	Tran	Date Considered 5/02	
			in conformance with MPEP 609; Draw next communication to applicant.	line through citation if

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JK.	FORMATION DISCLOSURE ST	ATEMENT	Applicants: Shunpei Y	AMAZAKI		#4
	MM 1 8 2001 E		Filing Date: April 12, 20	001	Group Art U	Jnit:-N/A 28.
2	**************************************	FOREIGN PATEN	IT DOCUMENTS			
xaminer iitial	TRADE Document Number	Date	Country	Class	Subclass	<u>Translation</u> Yes No
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1 1		artment of Commerce and Trademark Office	Atty Docket 0756-228	8	Serial No. 0	9/832,844
1 (	FORMATION OSCLOSURE STA	TEMENT	Applicants: Shunpei	YAMAZAKI		#5
, Paller	JAN 1 0 2092		Filing Date: April 12,	2001	Group Art	2826 Unit:- <del>1765</del>
	* None Carlo	U.S. PATENT	DOCUMENTS	<del>.</del>		
Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate
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Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation Yes No
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